

PATENT  
Attv. Dkt. No. AMAT/5320.Y1/DSM/BCVD/JW

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

**In re Application of:**

E. Schiave

Serial No.: 09/755,516

Confirmation No.: 5078

Filed: January 4, 2001

**For: Apparatus Having Platforms  
Positioned for Precise  
Centering of Semiconductor  
Wafers During Processing**

Group Art Unit: 1763

Examiner: K. Moore

MAIL STOP

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**Dear Sir:**

**CERTIFICATE OF FACSIMILE  
TRANSMISSION UNDER 37 CFR 1.8**

I hereby certify that this correspondence and the documents referred to as attached therein are being facsimile transmitted to the U.S. Patent and Trademark Office to the fax number indicated by the Examiner, namely, fax number 703/872-9311 to the attention of the named Examiner, on the date below.

8/18/2003  
Date

Signature John D. Edwards

**RESPONSE TO OFFICE ACTION DATED APRIL 28, 2003**

In response to the Office Action dated April 28, 2003, having a shortened statutory period for response extended one month to expire on August 28, 2003, please enter this response and reconsider the claims pending in the application for reasons discussed below. The Commissioner is hereby authorized to charge \$108.00 to counsel's Deposit Account No. 20-0782/AMAT/5320.Y1/RDE, for six additional claims and any other fees required to make this response timely and acceptable to the Office.